

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

MEIER *et al.*

Application No.: 10/529,765

Filed: November 3, 2005

For: **Cleaning Device for Cleaning Process
Gas of a Reflow Soldering System**

Confirmation No.: 5840

Art Unit: 1797

Examiner: PHAM, Minh Chau Thi

Atty. Docket: 2380.0010000

Comments on Statement of Reasons for Allowance

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Mail Stop: Issue Fee

Sir:

Applicants thank the Examiner for indicating the allowability of claims 1, 3, 4, 7-11, 13, 14, and 16-20 in the Notice of Allowability dated April 12, 2010.

Comments on Statement of Reasons for Allowance

Applicants note the Examiner's Statement of Reasons for Allowance presented on pages 2-4 of the Notice of Allowability. Applicants reserve the right to demonstrate claims 1, 3, 4, 7-11, 13, 14, and 16-20 are allowable over the art made of record for further reasons related to any of their recited features. Applicants further contend that reservation of this right does not give rise to any implication regarding whether the Applicants agree with or acquiesce in the reasoning provided by the Examiner in the Examiner's statement of reasons for allowance.

Respectfully submitted,

STERNE, KESSLER, GOLDSTEIN & FOX P.L.L.C.

Jason D. Eisenberg
Attorney for Applicants
Registration No. 43,447

Date: 6/4/10

1100 New York Avenue, N.W.
Washington, D.C. 20005-3934
(202) 371-2600
1122615_1.DOC